



PATENT
5500-05001/TT1915D

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 09/217,213

Filed: December 21, 1998

Inventors:

Mark I. Gardner

H. Jim Fulford

Derick J. Wristers

Title: Semiconductor Fabrication
Employing Implantation of
Excess Atoms at the Edges
of a Trench Isolation
Structure

Examiner: Mai, Anh D.

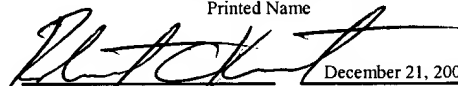
Group/Art Unit: 2814

Atty. Dkt. No: 5500-05001

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated below.

Robert C. Kowert

Printed Name


Signature

December 21, 2004

Date

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

The official Filing Receipt received by our office on August 30, 1999, lists one of the inventors as Derick J. **Wrister**. However, the correct inventor is Derick J. **Wristers**. I have provided a copy of the Filing Receipt with the change noted thereon. Applicants respectfully request that this change be made and a corrected Filing Receipt be reissued in the above-identified application.

Respectfully submitted,



Robert C. Kowert

Reg. No. 39,255

ATTORNEY FOR APPLICANTS

Meyertons, Hood, Kivlin, Kowert & Goetzel, P.C.

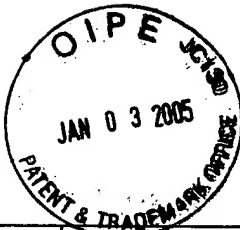
P.O. Box 398

Austin, TX 78767-0398

(512) 853-8800

Date: December 21, 2004

FILING RECEIPT
CORRECTED



UNITED STATES DEPARTMENT OF COMMERCE
Patent and Trademark Office
ASSISTANT SECRETARY AND COMMISSIONER
OF PATENTS AND TRADEMARKS
Washington, D.C. 20231 TT1915D

APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTORNEY DOCKET NO.	DRWGS	TOT CL	IND CL
09/217,213	12/21/98	2821	\$760.00	5500-05001	5	9	2

KEVIN L DAFFER
CONLEY ROSE & TAYSON
P O BOX 3267
HOUSTON TX 77253-3267

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts of Application" ("Missing Parts Notice") in this application, please submit any corrections to this Filing Receipt with your reply to the "Missing Parts Notice." When the PTO processes the reply to the "Missing Parts Notice," the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

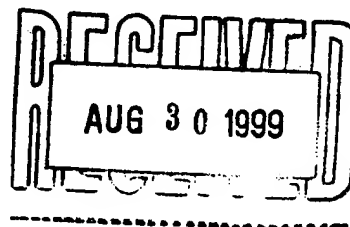
Applicant(s) MARK I. GARDNER, CEDAR CREEK, TX; H. JIM FULFORD,
AUSTIN, TX; DERICK J. WRISTER, AUSTIN, TX.
WRISTERS

CONTINUING DATA AS CLAIMED BY APPLICANT-
THIS APPLN IS A DIV OF 08/923,181 09/04/97 PAT 5,891,787

IF REQUIRED, FOREIGN FILING LICENSE GRANTED 01/14/99
TITLE

SEMICONDUCTOR FABRICATION EMPLOYING IMPLANTATION OF EXCESS ATOMS AT
THE EDGES OF A TRENCH ISOLATION STRUCTURE

PRELIMINARY CLASS: 438



DATA ENTRY BY: SMITH, ANITA

TEAM: 13 DATE: 08/24/99

(See reverse for new important information)